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Dated: October 9, 2007 Signature: (Andrew T. Zidel)

Docket No.: SCEI 3.0-200
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Keisuke Inoue

Application No.: 10/812,155

Group Art Unit: 2116

Filed: March 29, 2004

Examiner: S. Stoynov

For: METHODS AND APPARATUS FOR
ACHIEVING THERMAL MANAGEMENT
USING PROCESSOR MANIPULATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

It is respectfully requested that the references listed on the enclosed form be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each non-patent reference and each unpublished application is enclosed. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

In the event that any additional fee is due in connection with the present Information Disclosure Statement, the Commissioner is hereby authorized to charge the same to our Deposit Account No. 12-1095.

Dated: October 9, 2007

Respectfully submitted,

By (Signature)
Andrew T. Zidel

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